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## **BIB DATA SHEET**

								CONFI	RMAT	ION NO. 3543
SERIAL NUM 10/594,54		FILING or DATI 09/27/2	E 2006		CLASS 134	GR	GROUP ART UNIT 1792		ATTORNEY DOCKET NO. 33082M354	
RULE  APPLICANTS Hiroki Ohno, Yamanashi, JAPAN; Kenji Sekiguchi, Yamanashi, JAPAN; ***CONTNUING DATA***** This application is a 371 of PCT/JP2005/007450 04/19/2005  ***FOREIGN APPLICATIONS*** JAPAN 2004-128746 04/23/2004										
** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 06/25/2008										
Foreign Priority claimed			Met after Allowance		STATE OR COUNTRY JAPAN		HEETS AWINGS 7	TOTAL CLAIMS 24		INDEPENDENT CLAIMS 7
ADDRESS  SMITH, GAMBRELL & RUSSELL 1130 CONNECTICUT AVENUE, N.W., SUITE 1130 WASHINGTON, DC 20036 UNITED STATES  TITLE  Substrate Cleaning Method, Substrate Cleaning Equipment, Computer Program, and Program Recording Medium										
RECEIVED	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:						□ All Fees □ 1.16 Fees (Filing) □ 1.17 Fees (Processing Ext. of time) □ 1.18 Fees (Issue) □ Other □ Credit			